



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814
Examiner: Mr. Nathan W. Ha

In re PATENT APPLICATION of:

Applicant : Makoto TERUI et al.
Appln. No. : 10/022,268
Filed : December 20, 2001
For : SEMICONDUCTOR DEVICE AND
METHOD OF FABRICATING SAME
Attorney Ref. : OKI 286

INFORMATION
DISCLOSURE
STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

This is an information disclosure statement submitted under 37 C.F.R. §1.97 - 1.98.

A Form PTO-1449 and copies of the references listed therein are attached. Since the references are all written in the Japanese language, Patent Abstracts of Japan summaries and computer-generated translations are also attached, for each of the references, in order to provide English-language information about the relevance of the references.

These references were cited in an Office Action by the Japanese Patent Office on the counterpart Japanese application. A copy of a translation of a relevant part of the Japanese Office Action is also attached in order to supply further English-language information about the references

In compliance with 37 C.F.R. §1.97(c), the \$180 fee set forth in 37 C.F.R. §1.17(p) is being submitted concurrently. If this remittance is accidentally missing, however, or

FEE ENCLOSED: \$ / 180.00
Pls charge any further
f to our Deposit Account
No. 18-0002

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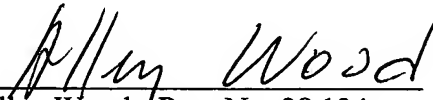
should any additional fees be needed, the Commissioner may charge such fees to our Deposit Account number 18-0002.

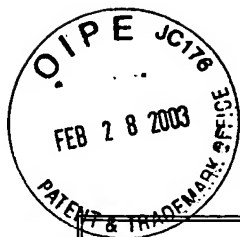
In view of the foregoing, it is respectfully requested that the Examiner consider the references and make them of record.

Respectfully submitted,

February 28, 2003
Date

AW:tlc


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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty. Docket OKI 286		Application No. 10/022,268	
				Applicant Makoto TERUI et al.			
				Filing Date December 20, 2001		Group 2814	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	JP 11-274367	10/8/99	JAPAN			Yes
	AJ	JP 11-345899	12/14/99	JAPAN			Yes
	AK	JP 08-306853	11/22/96	JAPAN			Yes
	AL	JP 2000-236144	8/29/00	JAPAN			Yes
	AM						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AN						
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							